

METHOD FOR FORMING A DEEP TRENCH CAPACITOR BURIED
PLATE

Appl. No. : 10/605,234 Confirmation No. 3393

Applicant : Chih-Han Chang,
Hsin-Jung Ho,
Chang-Rong Wu,
Chien-Jung Sun

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Examiner : NGUYEN, KHIEM D

Docket No. : NTCP0004USA

Customer No. : 27765

Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

Subject: Request for Continued Examination (RCE) in response to
the final Office Action mailed 11/22/2004

INTRODUCTORY COMMENTS

In response to the final Office action identified above, a request for continued examination (RCE) is made and the above-identified application is to be amended as indicated in the following sections. No new matter has been introduced by these amendments. A continued examination and consideration of all amendments are politely requested.